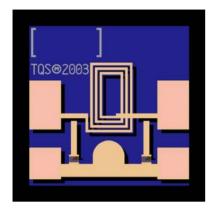


### **Bessel Filter**

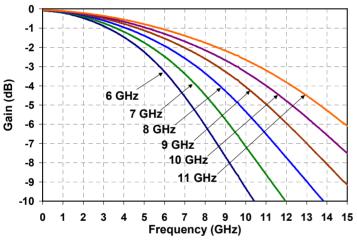
### TGB2010-EPU

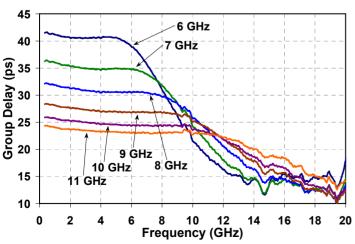


#### **Key Features and Performance**

- 6, 7, 8, 9, 10 & 11 GHz Filters
- <±1.25ps Group Delay to F<sub>o</sub>
- >15dB Return Loss to 2F<sub>0</sub>
- Filter Bandwidth ± 0.5 GHz
- 3MI Technology
- Chip Dimensions:
   0.49 x 0.49 x 0.10 mm
   (0.019 x 0.019 x 0.004 inches)

### **Preliminary Measured Performance**







**TGB2010-EPU** 

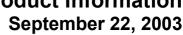
## TABLE I MAXIMUM RATINGS

Symbol	Parameter	Value	Notes
P <sub>IN</sub>	Input Continuous Wave Power	TBD	<u>1</u> /
T <sub>M</sub>	Mounting Temperature (30 Seconds)	320 °C	
T <sub>STG</sub>	Storage Temperature	-65 to 150 °C	

1/ These ratings represent the maximum operable values for this device

## TABLE II PART NUMBER DESIGNATIONS

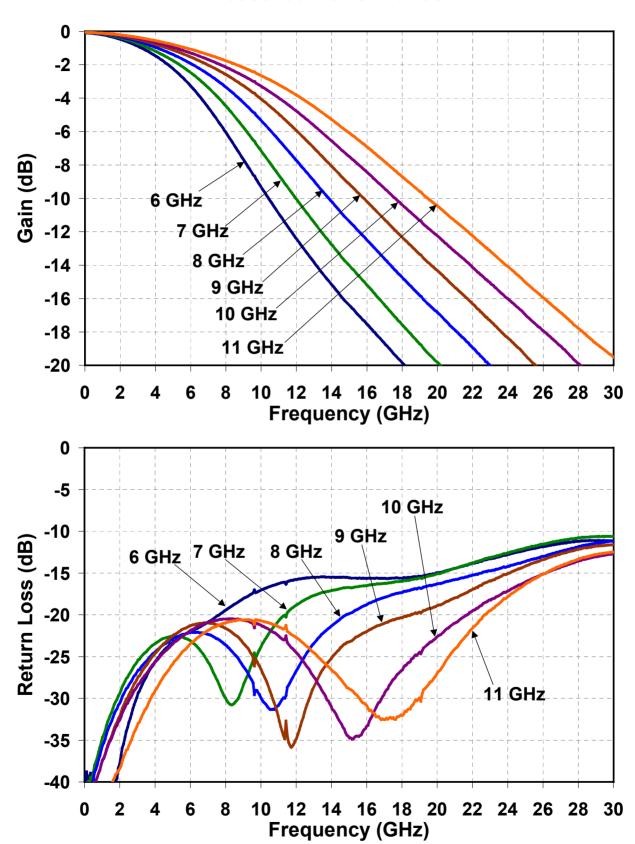
Part No	Cutoff Frequency
TGB2010-00-EPU	Thru
TGB2010-06-EPU	6 ± 0.5 GHz
TGB2010-07-EPU	7 ± 0.5 GHz
TGB2010-08-EPU	8 ± 0.5 GHz
TGB2010-09-EPU	9 ± 0.5 GHz
TGB2010-10-EPU	10 ± 0.5 GHz
TGB2010-11-EPU	11 ± 0.5 GHz





### **Measured Performance**

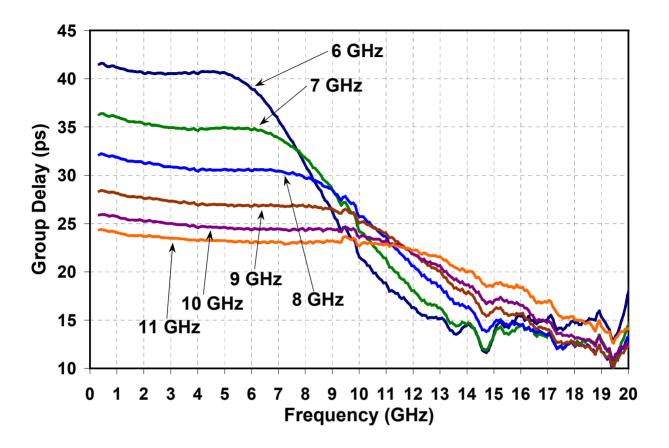
### **TGB2010-EPU**





TGB2010-EPU

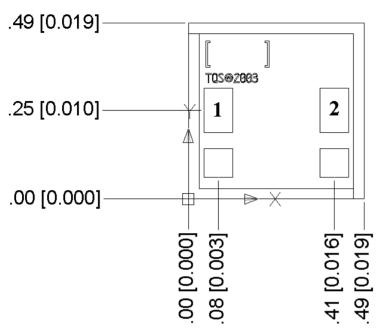
### **Measured Performance**





TGB2010-EPU

### **Mechanical Drawing**



Units: millimeters [inches]

Thickness: 0.10 [0.004] (reference only)

Chip edge to bond pad dimensions are shown to center of bond pads.

Chip size tolerance: ±0.05 [0.002]

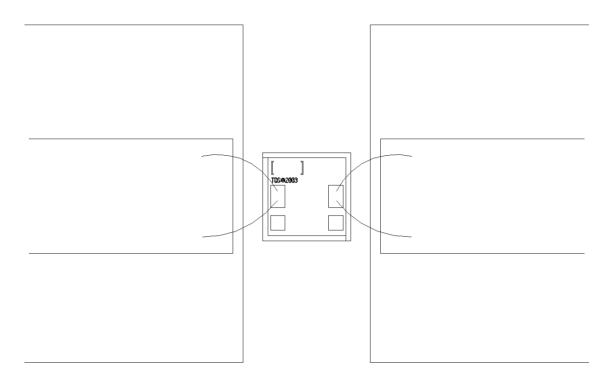
RF ground through backside

Bond Pad #1 RF Input 0.08 x 0.13 [0.003 x 0.005] Bond Pad #2 RF Output 0.08 x 0.13 [0.003 x 0.005]



**TGB2010-EPU** 

### **Assembly Drawing**





**TGB2010-EPU** 

### **Assembly Process Notes**

#### Reflow process assembly notes:

- Use AuSn (80/20) solder with limited exposure to temperatures at or above 300°C. (30 seconds maximum)
- An alloy station or conveyor furnace with reducing atmosphere should be used.
- No fluxes should be utilized.
- Coefficient of thermal expansion matching is critical for long-term reliability.
- Devices must be stored in a dry nitrogen atmosphere.

#### Component placement and adhesive attachment assembly notes:

- Vacuum pencils and/or vacuum collets are the preferred method of pick up.
- Air bridges must be avoided during placement.
- The force impact is critical during auto placement.
- Organic attachment can be used in low-power applications.
- Curing should be done in a convection oven; proper exhaust is a safety concern.
- Microwave or radiant curing should not be used because of differential heating.
- Coefficient of thermal expansion matching is critical.

#### Interconnect process assembly notes:

- Thermosonic ball bonding is the preferred interconnect technique.
- Force, time, and ultrasonics are critical parameters.
- · Aluminum wire should not be used.
- Maximum stage temperature is 200°C.

GaAs MMIC devices are susceptible to damage from Electrostatic Discharge. Proper precautions should be observed during handling, assembly and test.